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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/530,226-Conf. #1035	
			Filing Date	August 26, 2005	
			First Named Inventor	Oemer Uensal	
			Art Unit	1745	
			Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attorney Docket Number	15588-00009-US

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Examiner Initials ¹	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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					1*
Examiner Signature	/Henry Hu/			Date Considered	08/01/2008

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